



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Kazuhiro TAKAHASHI et al.

Application No.: 09/749,926

Filed: December 29, 2000

For: EXPOSURE APPARATUS

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Examiner: H. Nguyen

Group Art Unit: 2851

February 24, 2003

7/10/Art B  
R. Tyson  
3/3/03

Commissioner for Patents  
**Box RCE**  
Washington, D.C. 20231

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PRELIMINARY AMENDMENT

Sir:

Prior to further examination on the merits, please amend the above-identified application as follows:

IN THE CLAIMS:

Please ADD new claims 14-16, as follows. For the Examiner's convenience, all claims currently pending in this application have been reproduced below:

1. An exposure apparatus, comprising:  
a light source;